Electronic Patent Application Fee Transmittal							
Application Number:	10519724						
Filing Date:	28-Dec-2004						
Title of Invention:	Device and method for the production of chlorotriflouride and system for etching semiconductor substrates using said device						
First Named Inventor/Applicant Name:	Franz Laermer						
Filer:	Gerard A. Messina/Kevin Kambo						
Attorney Docket Number:	10191/3980						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing	Fees						
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:	·						
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Filing a brief in support of an appeal	1402	1	540	540			
Post-Allowance-and-Post-Issuance:	'						
Extension of Times							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			540